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Donor-acceptor-pair emission characterization in N-B doped fluorescent SiC

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Abstract: In the present work, we investigated donor-acceptor-pair emission in N-B doped fluorescent 6H-SiC, by means of photoluminescence, Raman spectroscopy, and angle-resolved photoluminescence. The photoluminescence results were interpreted by using a band diagram with Fermi-Dirac statistics. It is shown that with N and B concentrations in a range of $10^{18} \ cm^{-3}$ the samples exhibit the most intense luminescence when the concentration difference (n-type) is about $4.6 \times 10^{18} \ cm^{-3}$. Raman spectroscopy studies further verified the doping type and concentrations for the samples. Furthermore, strong luminescence intensity in a large emission angle range was achieved from angle-resolved photoluminescence. The results indicate N-B doped fluorescent SiC as a good wavelength converter in white LEDs applications.

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1. Introduction

To date, white light-emitting diodes (LEDs) are the most promising candidates for the illumination market to replace conventional incandescent lamps as energy-saving and environment friendly light sources. One common method to realize white LEDs is using a UV or blue LED whose light is partially or fully used to optically excite wavelength converters such as dyes, phosphors, and semiconductors [1–4]. Although dyes could have high quantum efficiency, it is lack of long term stability as organic material.

Phosphors are the most common wavelength converters. Recent research on phosphorconverted white LEDs demonstrate very high quantum efficiency of phosphors (larger than 80 %), controllable correlated color temperature (CCT), and acceptable color rendering index (CRI) value of above 80 [5–9]. However, phosphors usually suffer from a relatively low conversion efficiency in the red color (low ninth CRI value: R_9) which is the main limit to its general CRI value [6, 7, 9]. Therefore, high-efficiency wavelength converters with high CRI value and long lifetime are indispensable.

With large optical bandgap, SiC can be tailored to emit light across the entire visible spectrum, as well as the near UV region by introducing different dopants. Although SiC has relatively inefficient light emission compared to the most recent high-efficiency nitride-based visible [10–14] and UV [15–18] LEDs or emitters due to its indirect bandgap, many scientifically interesting applications on impurity-doped SiC materials have been developed [19–22]. Recently, nitrogen (N) and boron (B) doped 6H-SiC has been proven as a highly efficient wavelength converter for white LEDs [23], and internal quantum efficiency as high as 95 % was achieved which shows the better performance than the most common phosphors. Combined donor-acceptor-pair (DAP) band luminescences from N-B and nitrogen-aluminium (N-Al) doped 6H-SiC can cover most of the visible spectral range and thus white light with CRI larger than 90 could be produced [24]. Furthermore, SiC is a well-established substrate material for nitride growth and has excellent thermal conductivity.

2. Experiments and results

To explore how N and B doping concentrations affect emission, five homoepitaxial layers of 6H-SiC with different doping concentrations were grown by Fast Sublimation Growth Process [25]. The growth process is driven by a temperature gradient created between the source, in a form of polycrystalline SiC plate, and the substrate. Boron was introduced into the epilayers by doping from the source and nitrogen incorporation was controlled by adjusting N_2 gas pressure during the growth. Epilayers with different concentrations of B and N were grown on 6H-SiC (0001) substrates with 1.4 degree off-orientation in the [1120] direction at growth temperature of 1725°C. Atomic dopant concentrations of the epilayers measured by secondary ion mass spectrometry (SIMS) are listed in Table 1, where N_A and N_D represent acceptor (B) and donor (N) concentrations respectively.

Table 1. Boron (N_A) and Nitrogen (N_D) Concentrations for Samples a, b, c, d, and e

	а	b	с	d	e
$N_A (10^{18} cm^{-3})$	8.0	6.9	6.9	4.4	5.2
$N_D (10^{18} \ cm^{-3})$	0.04	3.2	6.0	9.0	9.2
Conductive type	р	р	р	n	n



Fig. 1. (a) Measured PL spectra (inset: zoom-in for sample a, b, and c; PL intensity decreases in the order of d, e, c, b, a), (b) Band diagram of n-type SiC under excitation (black dots represent electrons and unfilled circles represent holes; electron and hole quasi-Fermi levels are represented by E_{FC} and E_{FV} respectively. $E_D \approx 0.17$ eV [26], $E_A \approx 0.72$ eV [27], and $E_g \approx 3.02$ eV [28]).

2.1. Photoluminescence

Photoluminescence (PL) measurements were realized by using a diode laser working at 377 nm as excitation source which was coupled to a reflected fluorescence microscope. The excitation power density was $0.02 W/cm^2$, and the measurements were performed at room temperature. The PL spectra are shown in Fig. 1(a). One can see that the high-level p-type sample (a) exhibits extremely low DAP emission intensity, while the low-level p-type samples (b, c) have relatively stronger DAP emissions but still at a low level. Intense DAP emission was observed in n-type samples (d, e) while the strongest DAP emission occurred in sample d with the largest concentration difference of $4.6 \times 10^{18} cm^{-3}$.

Despite the intensity differences, all the DAP emission spectra show the same peak wavelength at 587 nm (2.12 eV) and the same full width at half maximum (FWHM) of 120 nm. The spectrum shape of the DAP emission is usually determined by the coulomb interaction and phonon coupling rather than by the carrier populations [29, 30]. Due to the same dopant materials and experimental conditions, the FWHM is almost constant for all the illuminant samples. From the above results, it is clear that both the doping type and the concentration difference affect the DAP emission intensity but do not introduce a change in the peak wavelength and FWHM at this doping level.

The dependence of the DAP emission intensity on doping concentrations could be explained by using band diagram with Fermi-Dirac statistics. Figure 1(b) shows a schematic band diagram of n-type doped SiC under excitation condition. It is seen that all the acceptor states (E_A) are occupied by photo-excited holes due to the large ionization energy of acceptor states (E_A - E_V),

so the hole density at the acceptor states $p_A \cong N_A$. On the other hand, the electron density at donor states (E_D) under excitation is given by

$$n_D = N_D \cdot F_D. \tag{1}$$

due to the small ionization energy $(E_C - E_D)$. Here F_D is the occupancy probability of an electron on donor states. It can be represented by

$$F_D = \frac{1}{1 + \frac{1}{2} exp\left(\frac{E_D - E_{FC}}{kT}\right)}.$$
(2)

where E_{FC} is the electron quasi-Fermi level under excitation, k is the Boltzmann constant, and T is the absolute temperature.

The DAP recombination rate R_{DA} is proportional to the product of p_A and n_D , hence,

$$R_{DA} \propto N_D \cdot F_D \cdot N_A. \tag{3}$$

Large donor and acceptor doping concentrations are required to achieve intense DAP recombination according to Eq. (3). In addition, the n-type sample is more likely to achieve high electron density at donor states. That is because, E_{FC} is at a higher energy level in the n-type samples than in the p-type ones. When N_A of the samples are in the same level and the concentration difference $(N_D - N_A)$ increases, E_{FC} becomes larger and could be within the conduction band. As a result, F_D increases and a high electron density could be generated at donor states. This is in good accordance with our PL measurement results.

Carrier lifetime measurements of the samples were carried out by using 355 nm, 2 ns, 40 Hz laser pulses in the work [31]. The obtained carrier lifetimes from sample a to e are 0.5 ns, 30 ns, 0.5 μ s, 1.2 μ s, and 1.1 μ s respectively. Combined with PL results, it is found that the longer carrier lifetime is responsible for stronger emission intensity. Sample d with the largest concentration difference of $N_D - N_A$ has the longest carrier lifetime of 1.2 μ s, which is comparable to the values of common phosphors: 0.89 μ s in Ref. [32] and 1.4 μ s in Ref. [33].

However, very high $N_D - N_A$ will cause intra-band absorption of excitation light and severe Auger recombination, both of which reduce the emission efficiency. So optimal concentrations need to be further studied.

2.2. Raman spectroscopy

Raman scattering spectra of the 6H-SiC samples were acquired in a backscattering configuration using the 514.5 nm line from an Ar ion laser (5 mW). Longitudinal optical (LO) modes of the Raman spectra are shown in Fig. 2, and the mechanisms of the observed Raman shifts in pand n-type samples are different.

In p-type samples, very few acceptor states are ionized due to the large ionization energy, and the Raman shift is mainly attributed to the atomic size effect [34]. Boron atoms usually are believed to occupy Si lattice positions in SiC. The interatomic distance of a Si-C bond is longer than that of a B-C bond due to the smaller atomic radius of B. The biaxial tensile stress will be released which results in a decrease of the phonon oscillation frequency. So the LO mode shifts toward smaller wavenumbers with higher B concentrations.

In n-type samples, the predominant mechanism causing the Raman shift of the LO mode is the coupling interaction between LO phonons and overdamped plasmons [35, 36].

The plasmon frequency ω_P is given by

$$\omega_P = \sqrt{\frac{4\pi n e^2}{\varepsilon_{\infty} m^*}},\tag{4}$$



Fig. 2. LO mode of the Raman spectra (inset: positions of LO modes; peak height decreases in the order of a, b, c, e, d).

where $n, e, \varepsilon_{\infty}$, and m^* are the free carrier concentration, electron charge, optical dielectric constant, and effective mass of electron respectively. The LO mode is then redefined as longitudinal optical phonon-plasmon coupled (LOPC) mode.

From Eq. (4), it is seen that ω_P is proportional to \sqrt{n} . So the plasmon frequency increases with increasing the free electron concentration, which results in an enhancement of the coupling interaction between phonons and plasmons. Consequently, the LOPC mode would lower its intensity and shift toward higher wavenumbers. Usually, the LOPC mode is more sensitive to the presence of free electrons than to the free holes. This is in a good agreement with the results shown in Fig. 2, where the LOPC modes of n-type samples occur at significantly higher wavenumbers than the p-type ones. Although no obvious peak shift has been observed between sample d and e due to the relatively small concentration difference, the peak intensity of the LOPC mode decreases as expected when the free electron concentration $(N_D - N_A)$ increases from sample e to d.

2.3. Angle-resolved photoluminescence

Angle-resolved PL was measured on sample d by using a goniometer. The excitation light was fixed to a certain direction, and the observation (emission) angle varied from 0 (normal to the sample surface) to 80 degrees. From the acquired spectra shown in Fig. 3(a), one can see that the PL intensity decreases and its peak shifts toward shorter wavelength as the emission angle θ increases.

The PL intensity becomes lower because the internal reflection increases as the emission angle increases, hence, the emission light extracted out of the SiC sample decreases. From Fig. 3(b), it is also seen that the luminescence intensity at an angle of 80 degrees is still around 57 % of the one normal to the surface, which is quite promising among the most of commercial LEDs (less than 30 %).

In addition, this angular-dependent PL peak wavelength is attributed to the Fabry-Pérot microcavity interference effect, and similar phenomena have also been observed in Refs. [37,38].

The Fabry-Pérot equation

$$m\lambda = 2dn\cos\psi. \tag{5}$$

gives the condition for constructive interference of light undergoing multiple internal reflec-



Fig. 3. (a) Angular-dependent PL spectra, (b) emission angle versus peak shift and normalized PL intensity (%).

tions in a solid film or an *é*talon. In Eq. (5), *m* is the interference order, λ is the propagating wavelength, *d* is the *é*talon thickness, *n* is the refractive index of the *é*talon, and ψ is the wavefront propagation angle with respect to the surface normal. The relationship between ψ and θ can be represented by Snell's law

$$a\sin\psi = \sin\theta.$$
 (6)

Thus, the Fabry-Pérot equation can be rewritten as

$$m\lambda = 2d\sqrt{n^2 - \sin^2\theta}.$$
(7)

The N-B doped SiC film grown on the 6H-SiC substrate has a large refractive index difference at the SiC-air interface. Also due to its smooth surface, it acts as a Fabry-Pérot étalon and thus optical interference occurs. The DAP emission in SiC is broad as shown in the PL spectra. From Eq. (7), it is clear that the interference wavelength decreases as θ increases. The PL peak shifts toward shorter wavelengths as the emission angle increases and this is consistent with the observed results.

However, for the illumination application, the light source should not depend on the emission angle in terms of the peak wavelength. To improve it, nanostructuring of the surface to remove the Fabry-Pérot interference and increase the luminescence intensity at large emission angle should be interesting to study for a comparison.

3. Conclusion

In conclusion, five fluorescent SiC samples with varied B and N doping concentrations were investigated. It is found that n-type doping with both B and N concentrations larger than 10^{18} cm^{-3} is required to achieve intense DAP emission, and the concentration difference of the n-type sample needs to be larger than $4x10^{18}$ cm^{-3} as concluded from this study. The doping type and concentrations of the samples were then confirmed by analyzing the LO mode variation in Raman spectra.

The luminescence intensity at an emission angle of 80 degrees is found to be 57 % of the one normal to the surface. Angular-dependent PL spectra which arised from the Fabry-Pérot microcavity interference effect was also observed and expected to be removed by applying surface nanostructuring. With adjustment of doping concentrations, intense DAP emission with a broad spectral range was obtained making fluorescent SiC a good candidate of a wavelength converter in white LEDs.

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